



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

in re patent application of

Noboru MORITA, et al.

Serial No.:

10/766,921

Group Art Unit:

2818

Filing Date:

January 30, 2004

Examiner:

Berry, Renee R.

For:

METHOD OF FABRICATING SEMICONDUCTOR DEVICE USING

PLASMA-ENHANCED CVD

Honorable Commissioner of Patents Alexandria, Virginia 22313-1450

## **STATUS INQUIRY**

Sir:

Please indicate the status of the above-identified application, including an indication as to when the first Office Action on the merits may be expected.

Respectfully submitted,

Sean M. McGinn, Esq. Registration No. 34,386

Date:

McGinn & Gibb, PLLC Intellectual Property Law

8321 Old Courthouse Road, Suite 200

Vienna, Virginia 22182-3817

(703) 761-4100

Customer No. 21254